

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: ASEEM K. SRIVASTAVA ET AL.)
)
For: METHOD AND APPARATUS FOR)
MICRO-JET ENABLED, LOW-ENERGY ION)
GENERATION AND TRANSPORT IN)
PLASMA PROCESSING)

1-986 U.S. PTO
09/905043
07/13/01

#4

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §§ 1.56, 1.97 AND 1.98

Commissioner for Patents
Washington, D.C. 20231

Sir:

In compliance with the duty to disclose, applicants submit herewith a copy of each publication of which those designated by 37 CFR § 1.56 are aware; the publications are listed on attached form PTO-1449.

Consideration of this Information Disclosure Statement is respectfully requested, since the Examiner may consider the information provided herein material to the patentability of the subject application as defined in 37 CFR § 1.56.

I certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231 on	
July 13, 2001 (Date of Deposit)	
Jessica L. Walsh (Name of Person Mailing Paper)	
<i>Jessica L. Walsh</i> Signature	07/13/2001 Date

Since this Information Disclosure Statement is being filed within three months of the filing date of the subject application, no fee or certification under 37 CFR § 1.97 (e) is required.

However, in the event the Commissioner of Patents deems that any fee is required under 37 CFR §§ 1.16 and 1.17 in connection with this application, applicants' attorneys authorize that such fee be charged to Deposit Account No. 06-1130.

Respectfully submitted,

ASEEM K. SRIVASTAVA ET AL.

CANTOR COLBURN LLP
Applicants' Attorneys

By: 

Peter R. Hagerty
Registration No. 42,618
Customer Service #23413

Date: July 13, 2001
Address: 55 Griffin Road South, Bloomfield, Connecticut 06002
Telephone: (860) 286-2929